

L Numb r	Hits	S arch T xt	DB	Tim stamp
1	2329	display and (semiconductor) and (ion adj implant\$) and electrode and drain and gate	USPAT	2004/05/16 16:54
2	2202	display and (semiconductor) and (ion adj implant\$) and electrode and drain and gate and method	USPAT	2004/05/16 16:54
3	850	display and (semiconductor) and (ion adj implant\$) and electrode and drain and gate and method and capacitor	USPAT	2004/05/16 16:55